

Docket No.: 49959-118

1-19-01
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

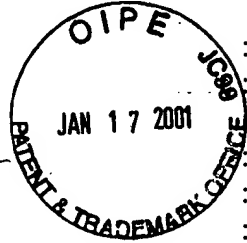
In re Application of

Lizhong Sun, et al.

Serial No.: 09/645,690

Filed: August 24, 2000

For: CU CMP POLISHING PAD CLEANING



Group Art Unit: 2812

Examiner: unknown

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to pending applications Serial No. 09/163,582 and Serial No. 09/359,141, which contain similar subject matter to the above-referenced application. The references cited in these applications are listed on the attached form PTO-1449.

The identification of these U.S. Patent Applications is not to be construed as a waiver of secrecy as to that application now or upon issuance of the present application as a patent. The Examiner is respectfully requested to consider the cited application and the art cited therein during examination.

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This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



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